

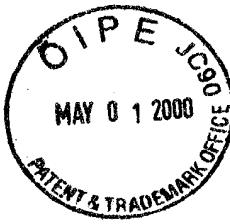
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

KIRA, et al.

Serial Number: 08/897,953

Filed: July 24, 1997



Group Art Unit: 2814

Examiner: D. Graybill

For: METHOD AND SYSTEM FOR FABRICATING SEMICONDUCTOR DEVICE

PETITION FOR EXTENSION OF TIME

Director of Patents and Trademarks  
Washington, D.C. 20231

Date: May 1, 2000

Sir:

Applicants petition the Commissioner of Patents and Trademarks to extend the time for response to the Office Action dated November 30, 1999, for two months from February 29, 2000 to April 30, 2000.

Attached please find a check in the amount of Three Hundred Eighty Dollars (\$380.00) to cover the cost of the extension. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340. This paper is filed in triplicate.

Respectfully submitted,  
ARMSTRONG, WESTERMAN, HATTORI  
McLELAND & NAUGHTON

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